

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

**Re application of:** Takehisa Yahiro

**Date Mailed** February 16, 2005

**Patent No.** 6,831,282 ~~B2~~

**Issued:** December 14, 2004

**Application No.** 10/000,458

**Filed:** November 30, 2001

**Confirmation No.** 2299

**For:** METHODS AND DEVICES FOR  
EVALUATING BEAM BLUR IN A  
CHARGED-PARTICLE-BEAM  
MICROLITHOGRAPHY APPARATUS

**Examiner:** Mary A. El Shammaa

**Art Unit:** 2881

**Attorney Reference No.** 4641-61273-01

**Certificate**  
**FEB 28 2005**  
**of Correction**

COMMISSIONER FOR PATENTS  
P.O. BOX 1450  
ALEXANDRIA, VA 22313-1450

REQUEST FOR CERTIFICATE OF CORRECTION

The following printing errors were noted in comparing the printed patent with the papers  
in the attorneys' files:

02/24/2005 SABRAHA: 00000031 10000458-  
01 FC:1811 100.00 0P

In the Specification:

Column 4, lines 31-32, "angle of convergence angle." should be --angle of convergence--  
(application, page 6, line 20).

Column 13, line 64, "µm's." should be --µm.-- (application, page 23, line 2).

Column 15, line 13, "micro lithography" should be --microlithography-- (10/9/03  
Amendment, page 3, claim 1).

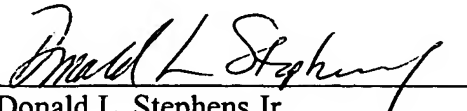
Column 16, line 46, "charted" should be --charged-- (10/9/03 Amendment, page 5,  
claim 10).

A Certificate of Correction is enclosed to make formal notice of the errors in the  
referenced patent. Our check in the amount of \$100.00 is enclosed.

Please return the enclosed postcard to confirm that these documents have been received.

Respectfully submitted,

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Docketing

MAR 02 2005

UNITED STATES PATENT AND TRADEMARK OFFICE  
CERTIFICATE OF CORRECTION

PATENT NO. : 6,831,282 *B2*

DATED : December 14, 2004

INVENTOR(S) : Takehisa Yahiro

It is certified that errors appear in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

Column 4,

Lines 31-32, "angle of convergence angle." should be --angle of convergence--.

Column 13,

Line 64, "μm's." should be --μm--.

Column 15,

Line 13, "micro lithography" should be --microlithography--.

Column 16,

Line 46, "charted" should be --charged--.

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PATENT NO. 6,831,282  
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(@ .30 per page)